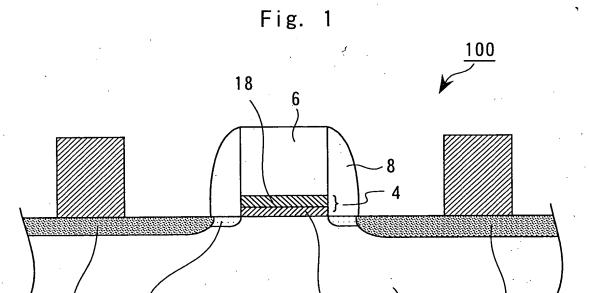
Title: METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE Inventors: KAWAHARA et al.
Atty Docket No.: 403001
Leydig, Voit & Mayer 202-737-6770

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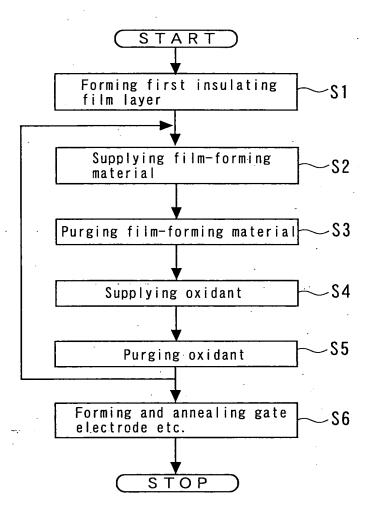
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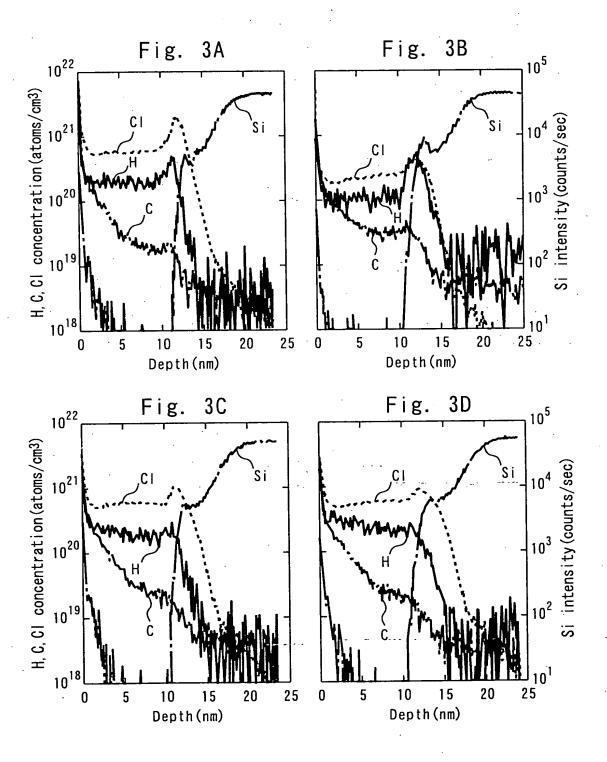
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Atty Docket No.: 403001
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Fig. 2





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Fig. 4

